



Atty. Dkt. No. 083847-0198

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Crocker et al.  
Title: Nanometer-Scale Engineered Structures, Methods and Apparatus  
for Fabrication thereof, and Applications to Mask Repair,  
Enhancement, and Fabrication  
Appl. No.: 10/689,547  
Filing Date: 10/21/2003  
Examiner: Ruggles  
Art Unit: 1756

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Applicants respectfully respond to the Notice of Non-Compliant Amendment,  
mailed on December 4, 2006.

The amendments to the abstract begin on page 2.